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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/618,624	07/15/2003	Noboru Matsuda	240349US2TTCCONT	5650
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OBLON, SPIVAK, MCCLELLAND, MAIER & NEUSTADT, P.C.			CAO, PHAT X	
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	•		2814	-
			DATE MAILED: 10/19/2005	

Please find below and/or attached an Office communication concerning this application or proceeding.

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	Application No.	Applicant(s)			
	10/618,624	MATSUDA ET AL.			
Office Action Summary	Examiner	Art Unit			
	Phat X. Cao	2814			
The MAILING DATE of this communication a Period for Reply	ppears on the cover she	et with the correspondence address			
A SHORTENED STATUTORY PERIOD FOR REF WHICHEVER IS LONGER, FROM THE MAILING - Extensions of time may be available under the provisions of 37 CFR after SIX (6) MONTHS from the mailing date of this communication. - If NO period for reply is specified above, the maximum statutory perion. - Failure to reply within the set or extended period for reply will, by state Any reply received by the Office later than three months after the may be earned patent term adjustment. See 37 CFR 1.704(b).	DATE OF THIS COMMI 1.136(a). In no event, however, m od will apply and will expire SIX (6) tute, cause the application to become	JNICATION. ay a reply be timely filed MONTHS from the mailing date of this communication. ne ABANDONED (35 U.S.C. § 133).			
Status					
1) Responsive to communication(s) filed on 08	August 200 <u>5</u> .				
2a)⊠ This action is FINAL . 2b)□ T	This action is FINAL . 2b) This action is non-final.				
•—	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is				
closed in accordance with the practice unde	r Ex parte Quayle, 1935	C.D. 11, 453 O.G. 213.			
Disposition of Claims		·			
4) ☐ Claim(s) 1-18 and 20 is/are pending in the a 4a) Of the above claim(s) is/are withd 5) ☐ Claim(s) is/are allowed. 6) ☐ Claim(s) 1-18 and 20 is/are rejected. 7) ☐ Claim(s) is/are objected to. 8) ☐ Claim(s) are subject to restriction and	rawn from consideration				
Application Papers					
9) The specification is objected to by the Examination The drawing(s) filed on is/are: a) and an applicant may not request that any objection to the Replacement drawing sheet(s) including the correction of the correction o	ccepted or b) objecte he drawing(s) be held in ab rection is required if the dra	eyance. See 37 CFR 1.85(a). wing(s) is objected to. See 37 CFR 1.121(d).			
Priority under 35 U.S.C. § 119					
 12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some * c) None of: 1. Certified copies of the priority documents have been received. 2. Certified copies of the priority documents have been received in Application No. 09/667,559. 3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)). * See the attached detailed Office action for a list of the certified copies not received. 					
Attachment(s) 1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/Paper No(s)/Mail Date	Pape 08) 5) 🔲 Notic	iew Summary (PTO-413) r No(s)/Mail Date e of Informal Patent Application (PTO-152) :			

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DETAILED ACTION

1. The cancellation of claim 19 in Paper filed 8/8/05 is acknowledged.

Claim Objections

2. Claim 13 is objected to under 37 CFR 1.75(c), as being of improper dependent form for failing to further limit the subject matter of a previous claim. Applicant is required to cancel the claim(s), or amend the claim(s) to place the claim(s) in proper dependent form, or rewrite the claim(s) in independent form. Claim 13 repeats the subject matter of independent claim 11. It fails to further limit the subject matter of independent claim 11.

For example, claim 11, last 3 lines, recites:

"... and the second source regions are connected to each other at one end of the second gate electrode group and are separated from each other at the other end of the second gate electrode group,"

whereas claim 13 recites:

"... wherein the second source regions are connected to each other at one end of the second gate electrode group, and separated from each other at the other end of the second gate electrode group."

Clearly, dependent claim 13 recites the same subject matter as independent claim 11. Therefore, dependent claim 13 fails to further limit the subject matter of independent claim 11.

Claim Rejections - 35 USC § 102

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3. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
- 4. Claims 1-20 are rejected under 35 U.S.C. 102(b) as being anticipated by Shimizu (US. 4,663,644).

Regarding claim 1, Shimizu (Figs. 1 and 3E) discloses a semiconductor device comprising: a first electrode gate group 4 having a plurality of gate electrodes 4a formed on a semiconductor substrate 6 to be away from each other at first equal spacing 5; a first gate insulating film 2 (column 4, lines 67-68) formed on at least two surfaces of a first gate electrode 4a of the first gate electrode group 4; source contact 12 having a portion 13 formed separated from a first gate electrode 4a of the first electrode gate group 4 by a second spacing (see Fig. 3E, second spacing equals the sum of first spacing 5 and a spacing portion of layer 8) greater than the first spacing 5; and source regions 9 for electrically interconnecting the first gate electrode group 4 and the source contact 12.

Regarding claims 2-3, as discussed above, Shimizu (Figs. 1 and 3E) discloses the invention as claimed, including the source regions 9 are <u>electrically</u> connected to each other at one end of the first gate electrode group (right hand end) <u>by the source contact 12</u> and separated from each other at the other end of the first gate electrode (left hand end).

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Regarding claim 4, Shimizu (Figs. 1 and 3E) discloses a semiconductor device comprising: a first gate electrode group 4 having a plurality of gate electrodes 4a formed on a semiconductor substrate 6 to be away from each other at the first equal spacing 5; a first gate insulating film 2 (column 4, lines 67-68) formed on at least two surfaces of a first gate electrode 4a of the first gate electrode group 4a; second gate electrode group 4 having a plurality of gate electrodes 4a formed on the semiconductor substrate 6 to be away from each other at the first equal spacing 5; a second gate insulating film 2 (column 4, lines 67-68) formed on at least two surfaces of the second gate electrode 4a of the second gate electrode group 4; a source contact portion 13 between the first and second gate electrode groups 4 to be away from the first and second gate electrode groups 4 at a second spacing; and source regions 9 for electrically interconnecting the first gate electrode group 4 and the source contact 13, wherein the source regions 9 are electrically connected to each other at one end of the first gate electrode group 4 (right hand end) by the source contact 12, and separated from each other at the other end of the first gate electrode group 4 (left hand end).

Regarding claims 5-8, Shimizu (Figs. 1 and 3E) further discloses that the gate electrodes 4a of the first group 4 are connected to each other at the other end (not shown in Fig. 1, see Fig. 2), the first and second gate electrode groups 4 are formed in trench structures, and the diffused source regions 9, the source contact 12 and the first gate electrode group 4 constitute one MOS transistor.

Regarding claims 9-10, Shimizu (Fig. 1) also discloses a source electrode 12 on the semiconductor substrate, wherein the source contact portion 13 is an electrode

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drawn from the source electrode 12, and all the gate electrodes 4a of the first gate electrode group 4 are used as gates for a MOS transistor.

Regarding claims 11, 13 and 19, Shimizu (Figs. 1 and 3E) discloses a semiconductor device comprising: a first gate electrode group 4 (the rightmost group) having a plurality of gate electrodes 4a formed on a semiconductor substrate 6 to be away from each other at first equal spacing; a first gate insulating film 2 (column 4, lines 67-68) formed on at least two surfaces of a first gate electrode 4a of the first gate electrode group 4; a second gate electrode group 4 (the second rightmost group) having a plurality of gate electrodes 4a on the semiconductor substrate 6 to be away from each other at the first equal spacing 5; a second gate insulating film 2 (column 4, lines 67-68) formed on at least two surfaces of the second gate electrode 4a of the second gate electrode group 4; a third gate electrode group 4 (the third rightmost group) having a plurality of gate electrodes 4a formed on the substrate 6 to be away from each other at the first equal spacing 5; a third gate insulating film 2 (column 4, lines 67-68) formed on at least two surfaces of the third gate electrode 4a of the third gate electrode group 4; a first source contact portion 13 formed between the first and second gate electrode groups 4 to be away from the first and second gate electrode groups 4 at a second spacing; a second source contact portion 13 formed between the second and third gate electrode groups 4 to be away from one selected from the second and third gate electrode groups 4 at the second spacing, first source regions 9 which electrically interconnect the first gate electrode group 4 and the first source contact portion 13; and second source regions 9 which electrically interconnect the second gate electrode

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group 4 and the second source contact portion 13, wherein the first source regions 9 are <u>electrically</u> connected to each other at one end of the first gate electrode group 4 (right hand end) by the source contact electrode 12 and separated from each other at the other end of the first gate electrode group (left hand end), and the second source regions 9 are electrically connected to each other at one end of the second gate electrode group 4 (right hand end) by the source contact electrode 12 and separated from each other at the other end of the second gate electrode group (left hand end).

Regarding claims 12, 14, 15 and 16, Shimizu (Figs. 1 and 3E) further discloses that: the first and second gate electrode groups 4 are connected to each other at the other end (not shown in Fig. 1, see Fig. 2); the first and second gate electrode groups 4 are formed in trench structures; the diffused first source region 9, the first source contact portion 13, and the first gate electrode group 4 constitute one MOS transistor; and the diffused second source region 9, the second source contact portion 13, and the second gate electrode group 4 constitute another MOS transistor.

Regarding claims 17 and 18, Shimizu (Figs. 1 and 3E) further disclose that each of the first and second source contact portions 13 is an electrode drawn from a source electrode 12, and these portions are connected to each other (see Fig. 3E), and all the gate electrodes 4a of the first and second gate electrode groups 4 are used as gates for MOS transistors.

Regarding claim 20, Shimizu (Fig. 3E) also discloses that the second spacing (second spacing equals the <u>sum</u> of the first spacing 5 and a spacing portion of layer 8) is greater than the first spacing 5.

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Response to Arguments

5. Applicant argues that Shimizu does not suggest a gate insulating film formed on at least two surfaces of a gate electrode of the first gate electrode group as amended.

This argument is not persuasive because Shimizu's Fig. 1 clearly teaches a gate electrode group 4 having two gate electrodes 4a (column 3, lines 21-23), and a gate insulating film 2 (column 4, lines 67-68) formed on a bottom surface and on two side surfaces of a gate electrode 4a of the first gate electrode group 4. Therefore, Shimizu's Fig. 1 does suggest the invention as claimed.

Conclusion

6. Applicant's amendment necessitated the new ground(s) of rejection presented in this Office action. Accordingly, **THIS ACTION IS MADE FINAL**. See MPEP § 706.07(a). Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the date of this final action.

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7. Any inquiry concerning this communication or earlier communications from the

examiner should be directed to Phat X. Cao whose telephone number is 571-272-1703.

The examiner can normally be reached on M-F.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's

supervisor, Wael Fahmy can be reached on 571-272-1705. The fax phone number for

the organization where this application or proceeding is assigned is 571-273-8300.

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PC

October 17, 2005

PHAT X. CAO

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